

L Number	Hits	Search Text	DB	Time stamp
1	3566	((257/40) or (257/88) or (257/99)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:12
2	28307	(oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:13
4	1930	conductive near2 (member\$1 and lead\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:14
5	1	(((257/40) or (257/88) or (257/99)).CCLS.) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and (conductive near2 (member\$1 and lead\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:14
3	683	((257/40) or (257/88) or (257/99)).CCLS.) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:20
6	444	(((257/40) or (257/88) or (257/99)).CCLS.) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and (anode\$1 and cathode\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:21
7	203	(((257/40) or (257/88) or (257/99)).CCLS.) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and (anode\$1 and cathode\$1)) and (lead\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 14:21
10	7	"5734225"   "5855994"   "5895228"   "5994836"   "6191433"   "6320311"   "6399210"   "2001/0019133"   "2001/0022497").PN.	USPAT	2004/09/02 14:51
11	0	6656611.URPN.	USPAT	2004/09/02 14:52
12	2	((remov\$3 near4 (organic or polymer)) near2(layer\$1 or film\$1)) same ((laser near2 ablat\$4) and (dry near2 etch\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:26
13	360	((remov\$3 near4 (organic or polymer)) near2(layer\$1 or film\$1)) same (dry near2 etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:24
14	6	((remov\$3 near4 (organic or polymer)) near2(layer\$1 or film\$1)) same (dry near2 etch\$3)) and (laser near2 ablat\$4)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:38
15	362	((laser near2 ablat\$4) same (dry near2 etch\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:34
16	35	((laser near2 ablat\$4) same (dry near2 etch\$3))) same ((organic or polymer) near2 (layer\$1 or film\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:35
17	161	((laser near2 ablat\$4) near5 (dry near2 etch\$3))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2004/09/02 16:34

18	23	((laser near2 ablat\$4) near5 (dry near2 etch\$3)) same ((organic or polymer) near2 (layer\$1 or film\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:47
19	49	((remov\$3 near4 (organic or polymer)) near2(layer\$1 or film\$1)) same (dry near2 etch\$3) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:38
20	217	((organic or polymer) near2 (layer\$1 or film\$1)) near5 (laser near2 ablat\$4))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:54
21	22	((organic or polymer) near2 (layer\$1 or film\$1)) near5 (laser near2 ablat\$4)) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:49
22	7	((organic or polymer) near2 (layer\$1 or film\$1)) near5 (laser near2 ablat\$4)) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and (dry near2 etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:50
23	15591	remov\$3 near5((organic or polymer) near2 (layer\$1 or film\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:55
24	773	(remov\$3 near5((organic or polymer) near2 (layer\$1 or film\$1)) ) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:55
25	192	((remov\$3 near5((organic or polymer) near2 (layer\$1 or film\$1)) ) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and (dry near2 etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:57
26	46	((remov\$3 near5((organic or polymer) near2 (layer\$1 or film\$1)) ) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and ((dry near2 etch\$3) near5 ((organic or polymer) near2 (layer\$1 or film\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 16:58
-	7957	((438/82) or (438/99) or (438/149) or (438/479) or (438/706) or (438/710) or (438/711) or (438/725) or (438/735) or (438/436) or (438/737) or (438/738) or (438/780) or (438/781) or (438/942) or (438/944)).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:16
-	28252	(oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/02 14:12
-	1363	((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and ((dry or anisotropic) near2 etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:37
-	7	((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and ((dry or anisotropic) near2 etch\$3) ) and (conduct\$3 near2 (member and lead))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:30
-	150	((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) same ((dry or anisotropic) near2 etch\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:25

-	19	((438/82) or (438/99) or (438/149) or (438/479) or (438/706) or (438/710) or (438/711) or (438/725) or (438/735) or (438/436) or (438/737) or (438/738) or (438/780) or (438/781) or (438/942) or (438/944)).CCLS.) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) same ((dry or anisotropic) near2 etch\$3) )	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:25
-	248	((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and ((dry or anisotropic) near2 etch\$3) ) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:32
-	26	((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) same ((dry or anisotropic) near2 etch\$3) ) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:42
-	835	((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:38
-	92	((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film)) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:38
-	15	((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and ((438/82) or (438/99) or (438/149) or (438/479) or (438/706) or (438/710) or (438/711) or (438/725) or (438/735) or (438/436) or (438/737) or (438/738) or (438/780) or (438/781) or (438/942) or (438/944)).CCLS.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/08/31 14:39
-	16	((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:04
-	8	("5550066") or ("6106352") or ("6060728") or ("6265319") or ("6358631") or ("6475836") or ("20020055210") or ("20020072139").PN.	USPAT; US-PGPUB	2004/08/31 14:55
-	1	("6699728").PN.	USPAT	2004/09/01 20:02
-	709	(anod\$2 same lead\$1) near10 substrate	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:03
-	22653	((anod\$2 same lead\$1) near10 substrate) and (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:04
-	16	((anod\$2 same lead\$1) near10 substrate) and (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device) and (((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:38

-	16	((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:06
-	16	((anod\$2 same lead\$1) near10 substrate ) and (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device) and (((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:06
-	0	((((anod\$2 same lead\$1) near10 substrate ) and (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device) and (((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2)) and ((anod\$2 same lead\$1) near10 substrate )	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:36
-	22650	(conductive near5 lead) same (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:36
-	22648	(conductive near5 lead) near5 (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:37
-	22648	((conductive near2 lead) near anode\$2) near5 substrate) near5 (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:43
-	16	(((conductive near2 lead) near anode\$2) near5 substrate) near5 (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and (((((dry or anisotropic) near2 etch\$3) near5 ((organic or polymer) near2 (layer or film))) and ((oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device))) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:38
-	0	((conductive near lead\$1) same anode\$2 same substrate) ) and ((anod\$2 same lead\$1) near10 substrate ) and (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)) and oxygen near5 gas\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:41
-	27	((conductive near lead\$1) same anode\$2 same substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:41
-	22648	((conductive near lead\$1) same anode\$2) same (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:44
-	22648	((conductive near lead\$1) same anode\$2) near5 (oled or (organic near2 light near2 emit\$4)) or ((organic or polymer) near2 device)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/09/01 20:44

